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INFO	RMATION	DISCLOSU	JRE	Complete if Known		
STATEMENT BY APPLICANT				Application Number	10/581,622	
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NON PATENT LITERATURE DOCUMENTS							
Examiner Initials*	Cite No 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²				
/LF/	1.	KIM, Y., et al., "Microstructure comparison of transparent and Opaque CVD SiC", <i>J. Am. Ceram. Soc.</i> , Vol. 78 (6), pp. 1571-1579, 1995.					
/LF/	2.	IVANOVA, L.M., et al., "Thermoelectric properties of vapor-grown polycrystalline Cubic SiC", Inorganic Materials, Vol. 42 (11), pp. 1205-1209, 2006.					

EXAMINER /Lawrence Ferguson/ D	ATE CONSIDERED	11/04/2009
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